

3-21-05

IFCWS



ED626382590US

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION:

Application No.: 10/789,638
Filing Date: February 27, 2004
First Inventor: David L. Bender

Attorney Docket: Solx 4
Examiner: Nadine G. Norton
Art Unit: 1765

For: SYSTEM FOR CONTINUOUS
GROWING OF MONOCRYSTALLINE
SILICON

PRELIMINARY AMENDMENT

Honorable Commissioner for Patents and Trademarks
P.O. Box 1450
Alexandria, VA 22313-1450

Date: March 18, 2005

Sir:

Please preliminarily amend the subject application as follows. Each section of this amendment document begins on a separate sheet in accordance with 37 CFR 1.121.

03/22/2005 BABRAHA1 00000141 10789638

01 FC:2201 400.00 0P
02 FC:2203 180.00 0P

Repln. Ref: 03/22/2005 BABRAHA1 0023171300
DAM:501866 Name/Number:10789638
FC: 9204 \$180.00 CR